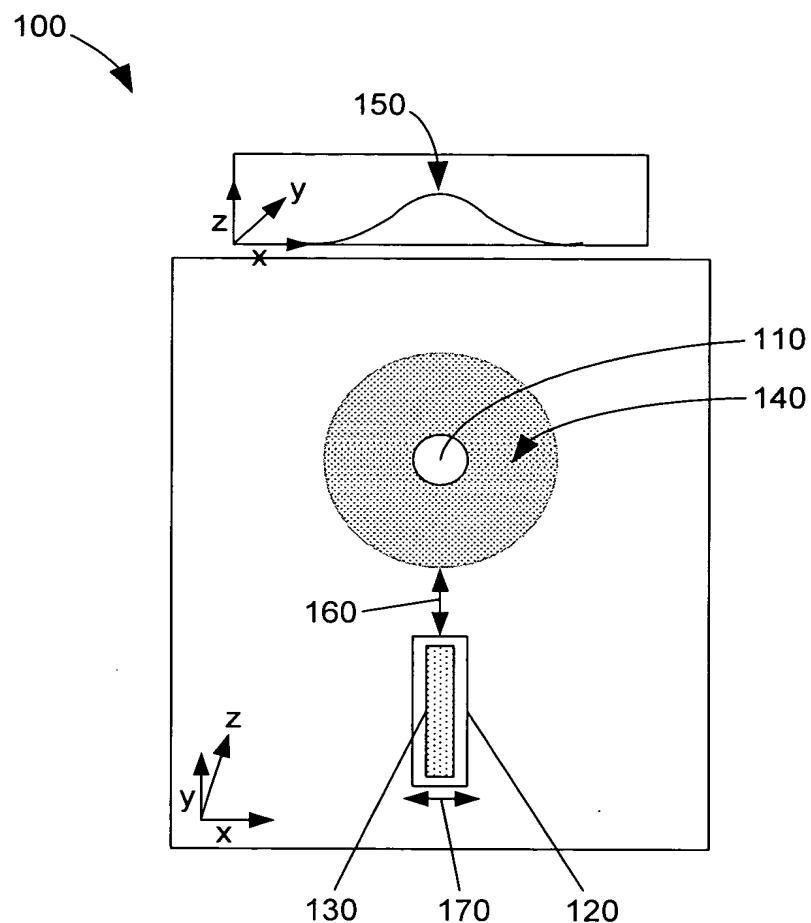
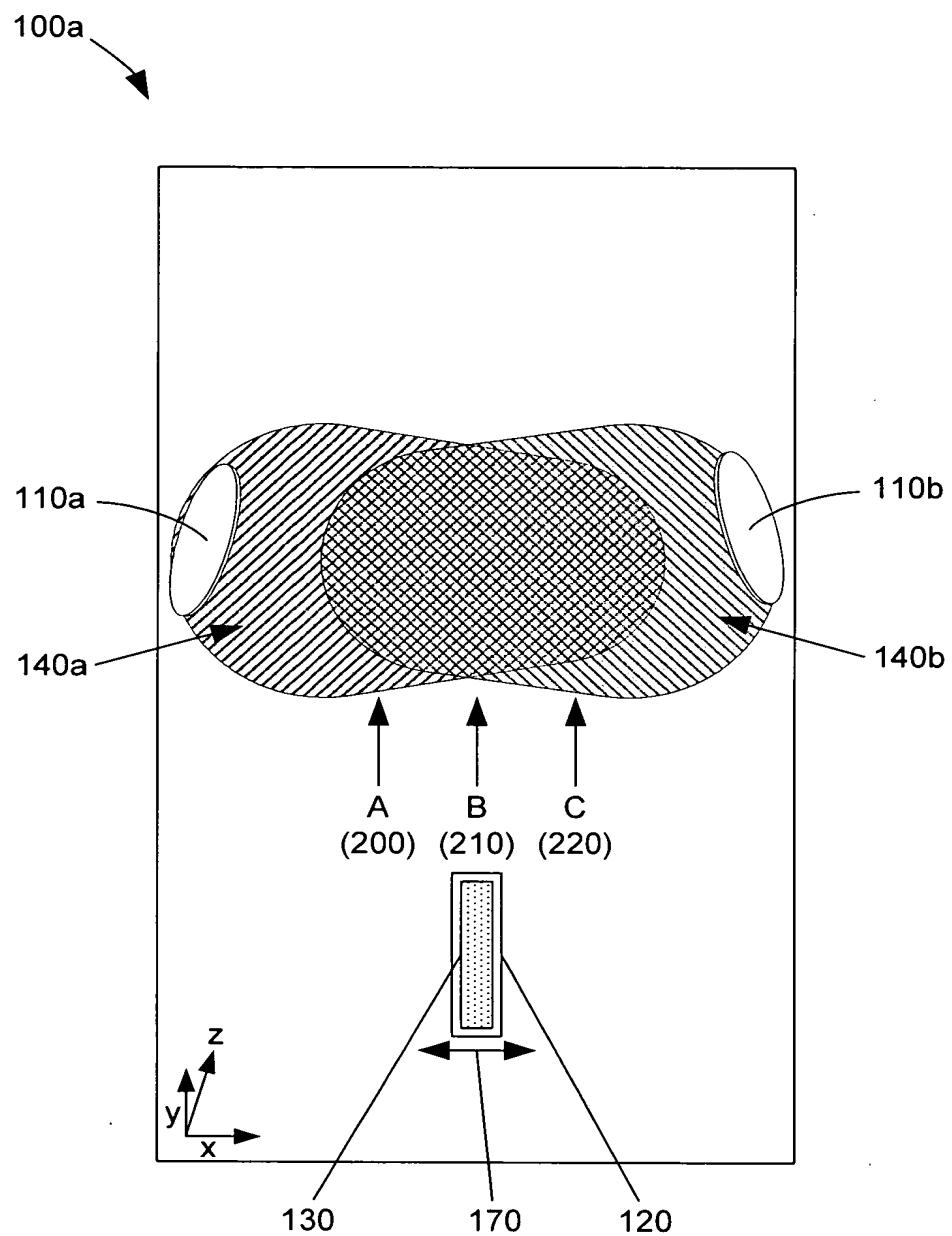


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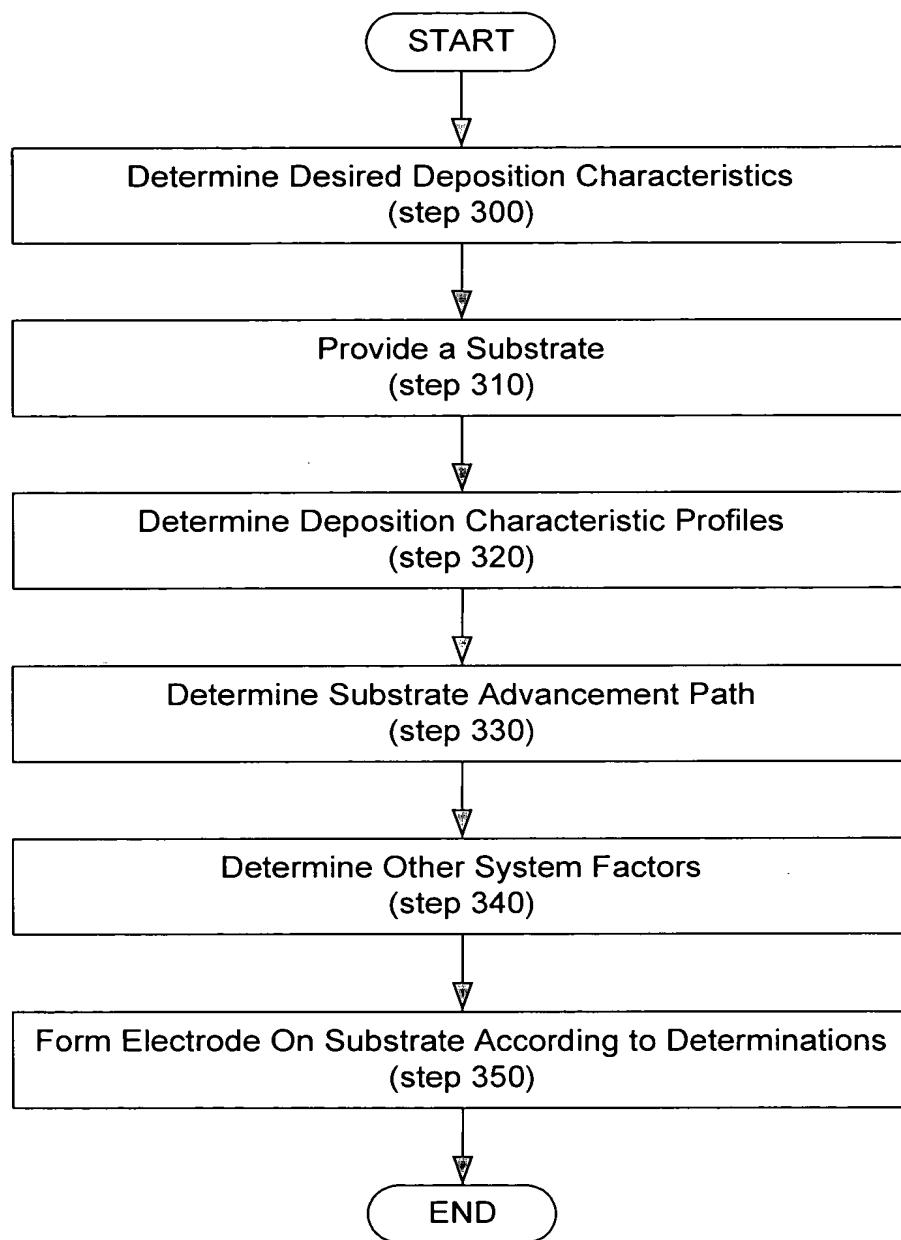
**Fig. 1**

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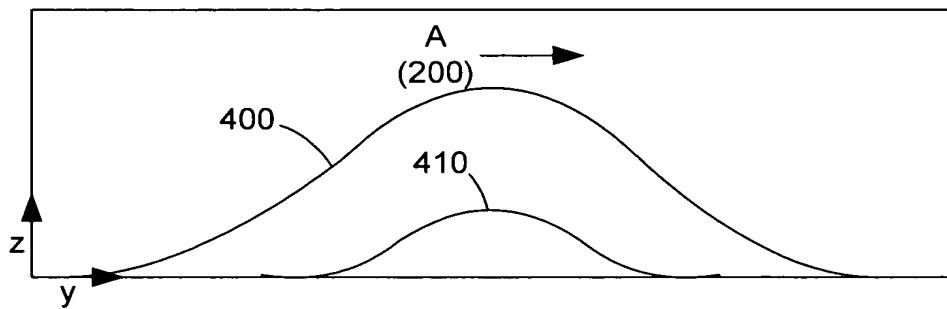
**Fig. 2**

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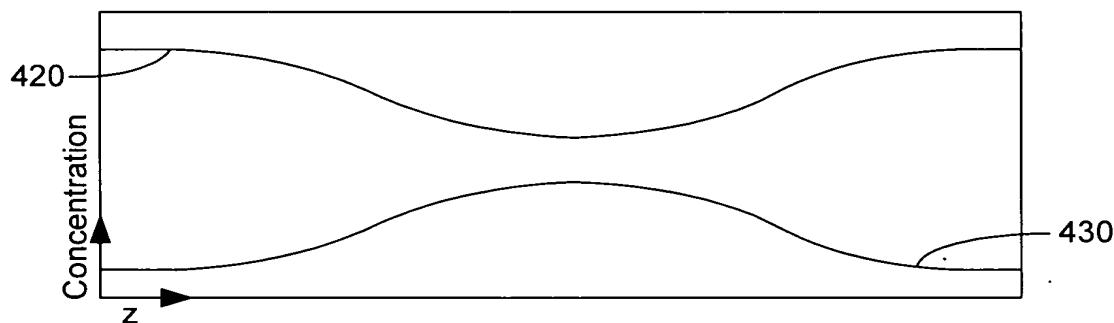


**Fig. 3**

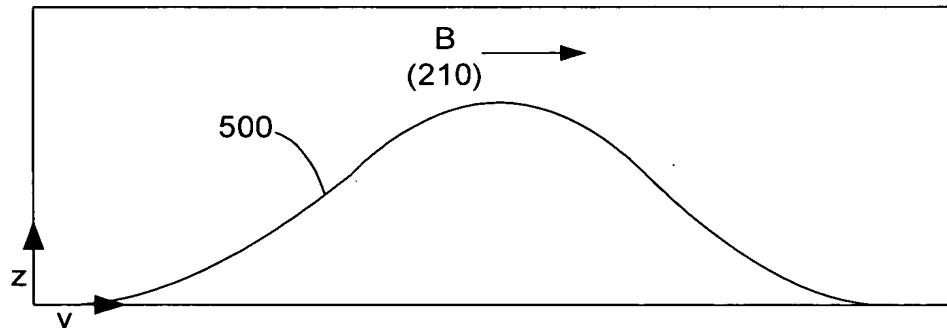
**4/8**



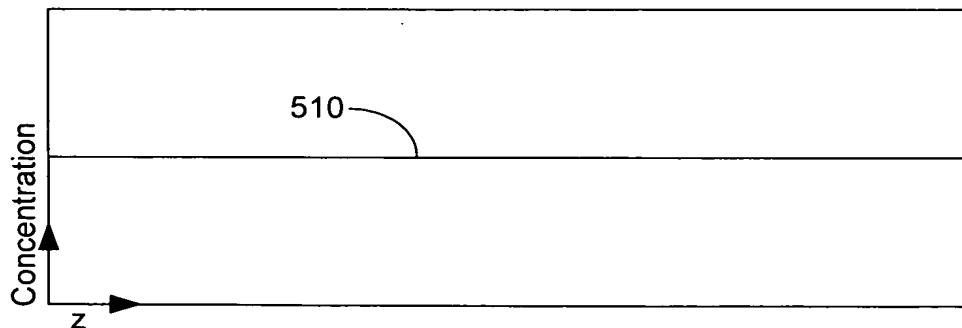
**Fig. 4A**



**Fig. 4B**

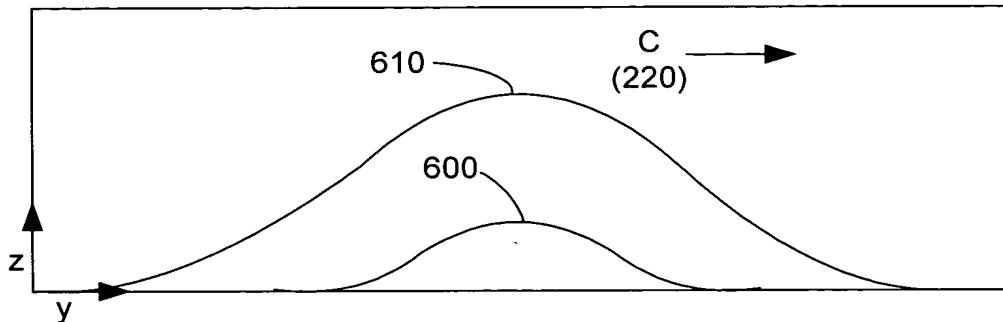


**Fig. 5A**

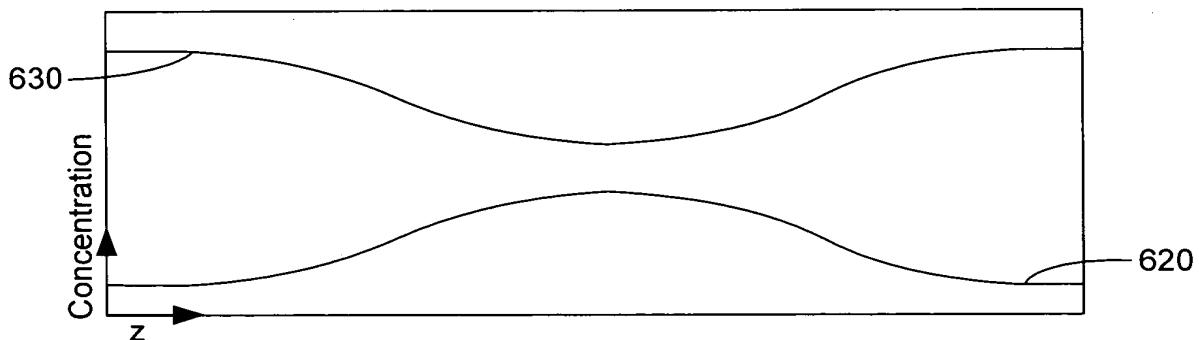


**Fig. 5B**

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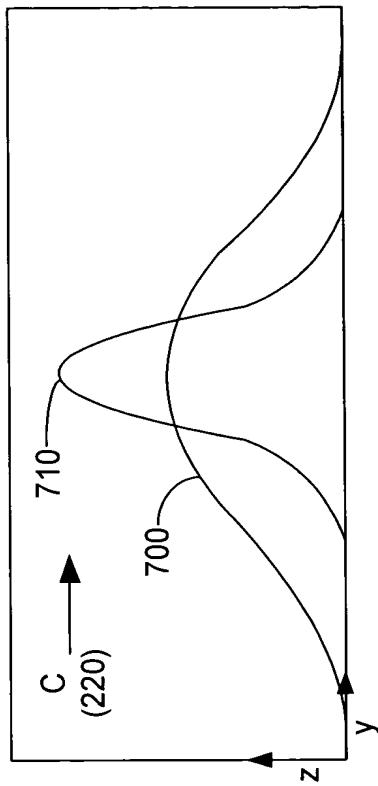


**Fig. 6A**

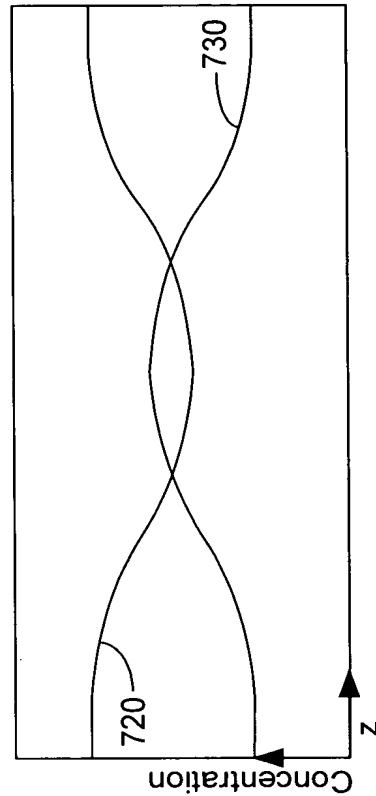


**Fig. 6B**

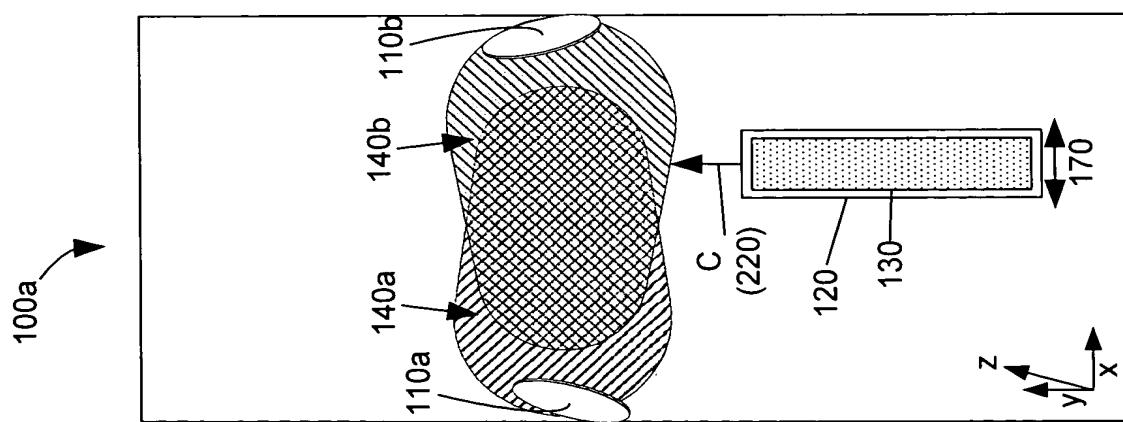
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**Fig. 7A**



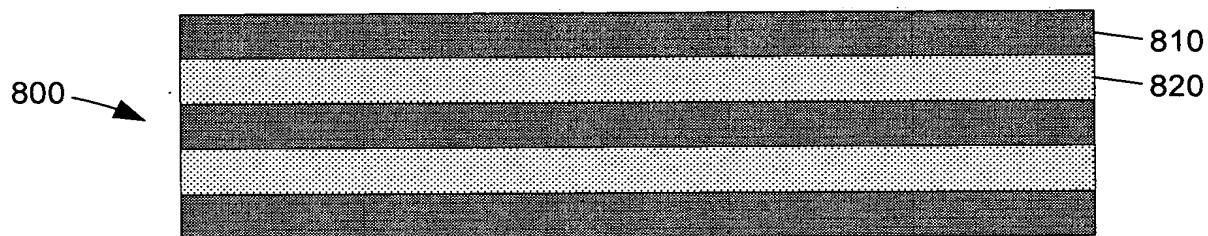
**Fig. 7B**



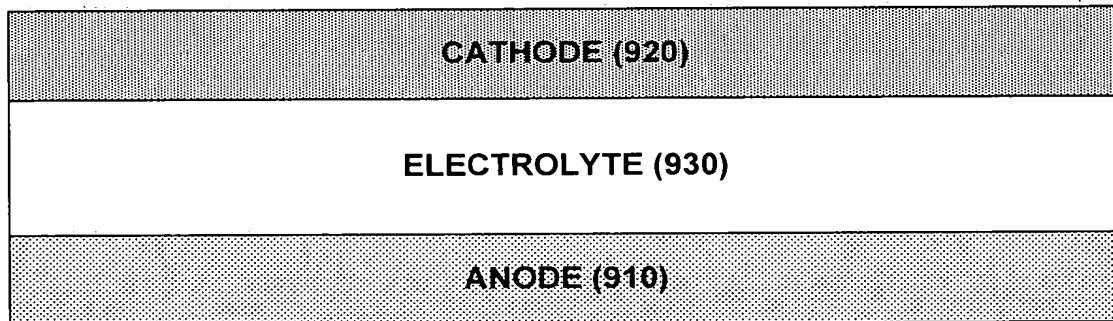
**Fig. 7**

**Title:** Method of Forming Thin-Film Electrodes  
**Inventor:** James O'Neil et al.  
**Docket No.:** 200312535-1

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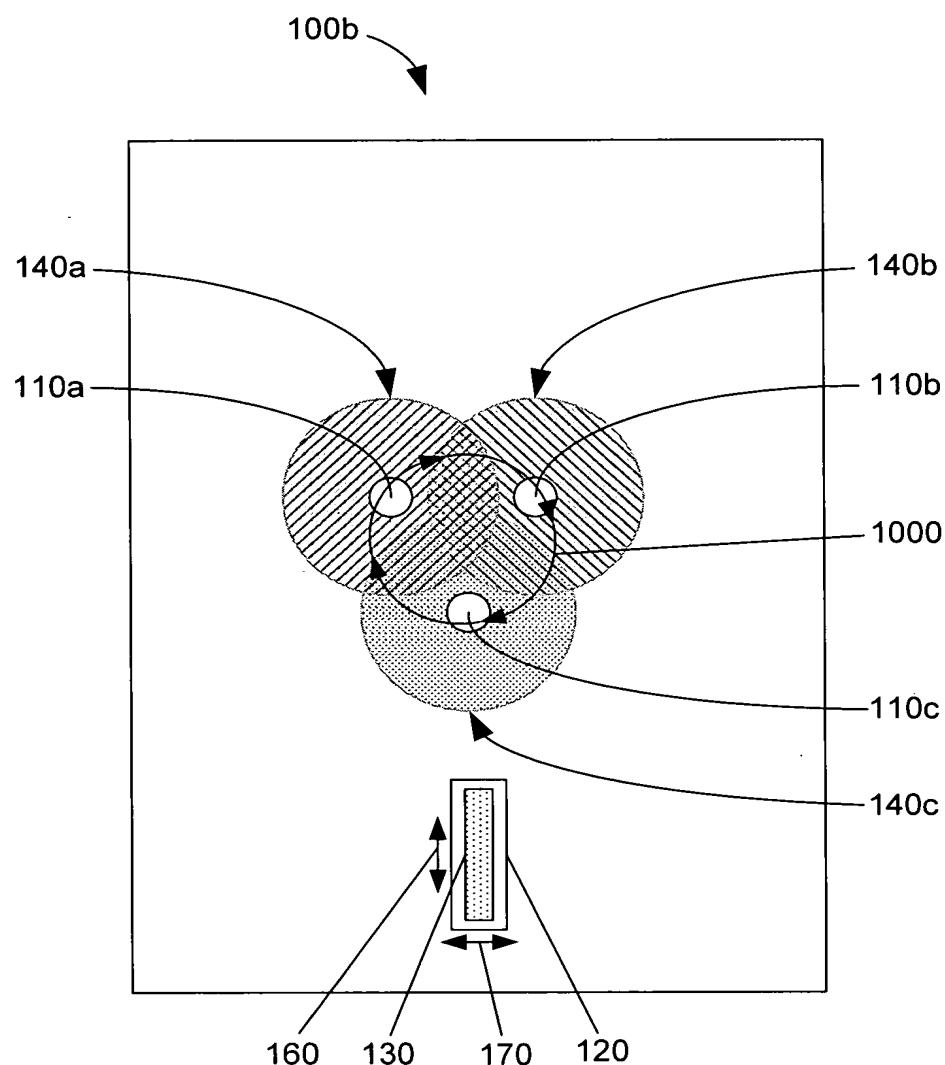


**Fig. 8**



**Fig. 9**

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**Fig. 10**